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PATENT  
03345-P0041A WWW/DWA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-----------------------|---|
| Applicant             | Piotr Strzyzewski                                       |
| Serial No. 10/601,508 | Filing Date: June 23, 2003                              |
| Title of Application: | Method And Device For Treating Semiconductor Substrates |
| Confirmation No. 9726 | Art Unit: 2829  |
| Examiner              | Monica D. Harrison                                      |

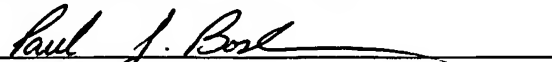
Mail Stop Non-Fee Amendment  
Commissioner for Patents  
Post Office Box 1450  
Alexandria, VA 22313-1450

**Response to Official Action**

In response to the Official Action of August 24, 2004, Applicant submits the following Remarks. Applicant believes that no fee is due in connection with the filing of this Response. However, if any fee is due, please charge Deposit Account No. 19-4516.

Mailing Certificate: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as *First Class Mail* in an envelope addressed to: Commissioner for Patents and Trademarks; Post Office Box 1450; Alexandria, VA 22313-1450.

November 22, 2004

  
Paul Bosley